



MP
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tetsuhiro Iwai et al.
Serial No.: 10/621,497
Filed: July 17, 2003
Title: "PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD"
Docket No.: 35908

LETTER

Mail Stop MISSING PARTS
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed herewith are 7 sheets of formal drawings for filing in the above-identified application.

Respectfully submitted,

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By 
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September 12, 2003

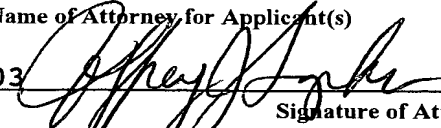
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Missing Parts, Commissioner of Patents, P.O. Box 1450, Alexandria, Va. 22313-1450 on the date indicated below.

Jeffrey J. Sopko

Name of Attorney for Applicant(s)

09/12/2003

Date


Signature of Attorney